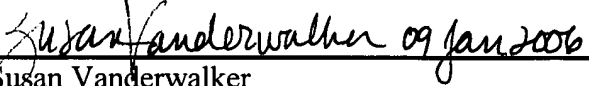




JFW

IN THE UNITED STATES PATENT OFFICE
Attention: Examiner Matthew C. LANDAU
Group Art Unit: 2815

Applicants:	Yu-Chuan LIU; Chia-Ming LEE; I-Lee CHEN; and Jen-Inn CHYI	This is to certify that this document has been transmitted by U.S. MAIL, addressed to the U.S. Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on Monday, January 9, 2006  Susan Vanderwalker
Title:	Light-Emitting Device and Manufacturing Process of the Light-Emitting Device	
Appl. No.:	10/814,872	
Filing Date:	31 MARCH 2004	

RESPONSE TO RESTRICTION REQUIREMENT

Honorable Commissioner of Patents
Alexandria, VA 22313-1450

Dear Commissioner:

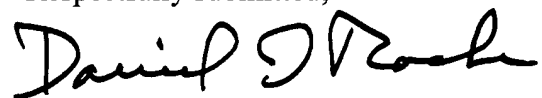
This *Response to Restriction Requirement* is in response to the Office Action indicated as having been mailed on December 12, 2005.

Applicant hereby elects to prosecute claims 1 through 14. This election is being made without traverse.

Monday, January 9, 2006

BAKER & McKENZIE LLP
130 E. Randolph Drive
Chicago, IL 60601
ph: 312-861-8608
fax: 312-698-2363
e-mail: david.i.roche@bakernet.com

Respectfully submitted,



David I. Roche
Reg. No. 30,797